

**IN THE UNITED STATES PATENT
AND TRADEMARK OFFICE**

Attorney Docket No. UCF-306DIV (which is a divisional of application SN: 10/082,658 filed 10/19/2001 which claims priority of SN: 09/881,620 filed June 14, 2001 and U. S. Provisional application 60/242,102 filed October 20, 2000)

Serial No.: 09/____

Filed: ____/____/____

Divisional Application of Serial No.: 10/082,658

Filed: 10/19/2001

First Named Inventor: Martin Richardson

For: EUV, XUV, AND X-RAY WAVELENGTH SOURCES CREATED FROM LASER PLASMA PRODUCED FROM LIQUID METAL SOLUTIONS,
AND NANO-SIZE PARTICLES IN SOLUTIONS

Examiner: COURTNEY D. THOMAS

Group: 2882

INFORMATION DISCLOSURE STATEMENT

Honorable Commissioner of Patents
and Trademarks
P O Box 1450
Alexandria, VA 22313-1450


Sir:

Pursuant to 37 CFR §§ 1.97 and 1.98, record is being made below in a form PTO-1449 of documents which the Patent Office may wish to consider in connection with examination of the above-identified patent application. It is respectfully requested that the cited documents be carefully considered by the Examiner and made of record in this case. As provided in § 1.97(g), no representation is made or intended that a thorough art search was made. As provided in 37 C.F.R. § 1.97(h), this Supplemental Information Disclosure Statement does not constitute an admission of any kind, and specifically is not an admission that the documents listed on the attached PCT-1449 are, or are considered to be, material to the patentability of the above-identified patent application, as defined in 37 C.F.R. § 1.56(b).

Copies of the cited references were previously submitted to the USPTO in the parent application No.: 10/082,658 filed 10/19/2001 and 09/881,620 filed June 14, 2001 and made of record. Applicants claim priority to said application under 35 U. S. C. § 120. Accordingly, copies of those documents are not provided with this Statement pursuant to 37 CFR § 1.98(d).

It is respectfully requested that the cited documents be carefully considered by the Examiner and made of record in the case.

Respectfully submitted,



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US DEPARTMENT OF COMMERCE
PATENT AND TRADEMARK OFFICE

APPLICANT: MARTIN RICHARDSON

FOR: EUV, XUV, AND X-RAY WAVELENGTH SOURCES CREATED FROM LASER PLASMA
PRODUCED FROM LIQUID METAL SOLUTIONS, AND NANO-SIZE PARTICLES IN SOLUTION

LIST OF ART CITED BY APPLICANT

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Courtney Thomas

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| | Examiner Courtney Thomas | Art Unit 2882 | Page 1 of 1 |

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